

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	2660	plasma and gas and semiconductor and floating and chamber	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/31 12:16
S2	10471	movable adj electrode	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/30 16:21
S3	7	S1 and S2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/30 16:24
S4	915	(438/795).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/08/30 17:00
S5	3	("6329304").URPN.	USPAT	OR	ON	2005/08/30 16:45
S6	22	("4495024" "4560590" "4575408" "4860687" "4975561" "5314848" "5332442" "5414244" "5430271" "5650082" "5790750" "6018616" "6064799" "6072163" "6080969" "6097005" "6111225" "6183565" "6207936" "6234788" "6275744" "6329304").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/08/30 16:46
S7	7311	floating and blowing	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/30 17:00
S8	208854	plasma and gas	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/30 17:00

S9	2068042	chamber	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/30 17:01
S10	221	S7 and S8 and S9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/30 17:01
S11	45	(plasma and gas and semiconductor and floating and chamber).clm.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/31 12:16